

**Today's Date: 3/13/2001** 

| DB Name                       | Query  | <u>Hit</u><br>Count | <u>Set</u><br><u>Name</u> |
|-------------------------------|--|---------------------|---------------------------|
| USPT,PGPB,JPAB,EPAB,DWPI,TDBD | "light emitting device" and<br>semiconductor adj layers and p-type adj<br>layer and n-type adj layer and reflector                                       | 15                  | <u>L11</u>                |
| USPT,PGPB,JPAB,EPAB,DWPI,TDBD | "light emitting device" and<br>semiconductor adj layers and p-type adj<br>layer and n-type adj layer and reflector<br>adj thickness                      | 0                   | <u>L10</u>                |
| USPT,PGPB,JPAB,EPAB,DWPI,TDBD | "light emitting device" and<br>semiconductor adj layers and p-type adj<br>layer and n-type adj layer and ohmic<br>and reflector adj thickness            | 0                   | <u>L9</u>                 |
| USPT,PGPB,JPAB,EPAB,DWPI,TDBD | "light emitting device" and<br>semiconductor adj layers and p-type adj<br>layer and n-type adj layer and ohmic<br>and mirror and micro adj meter         | 0                   | <u>L8</u>                 |
| USPT                          | "light emitting device" and<br>semiconductor adj layers and p-type adj<br>layer and n-type adj layer and ohmic<br>and mirror and micro adj meter         | 0                   | <u>L7</u>                 |
| USPT                          | "light emitting device" and<br>semiconductor adj layers and p-type adj<br>layer and n-type adj layer and ohmic<br>and mirror and micro meter             | 168410              | <u>L6</u>                 |
| USPT                          | "light emitting device" and<br>semiconductor adj layers and p-type adj<br>layer and n-type adj layer and ohmic<br>and mirror and micron                  | 1                   | <u>L5</u>                 |
| USPT                          | "light emitting device" and<br>semiconductor adj layers and p-type adj<br>layer and n-type adj layer and ohmic<br>and mirror and angstrom                | 6                   | <u>L4</u>                 |
| USPT                          | "light emitting device" and<br>semiconductor adj layers and p-type adj<br>layer and n-type adj layer and ohmic<br>and mirror adj4 thickness and angstrom | 0                   | <u>L3</u>                 |
| USPT                          | "light emitting device" and<br>semiconductor adj layers and p-type adj<br>layer and n-type adj layer and ohmic<br>and mirror adj4 thickness              | 2                   | <u>L2</u>                 |
| USPT                          | "light emitting device" and<br>semiconductor adj layers and p-type adj<br>layer and n-type adj layer and ohmic<br>and mirror and thickness               | 20                  | <u>L1</u>                 |